IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No
Filing Date April 4, 2001
Inventor David R. Hembree
Assignee Micron Technology, Inc.
Group Art Unit
Examiner V. Nguyen
Attorney's Docket No
Title: Methods of Processing a Workpiece, Methods of Communicating Signals With
Respect to a Wafer, and Methods of Communicating Signals Within a Workpiece
Processing Apparatus

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

ated: 5/1/06 Attorney:

Respectfully submitted,

Jame's D. Shaurette Reg. No. 39,833

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Sheet I of I

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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) APPLICANT: David R. Hembree									
		•		FILING DATE April 4, 2001			GROUP 2829		
U.S. PATENT DOCUMENTS									
*Examiner Initial		Document Number	Date	Name	Name		Subclass Filing Date If Appropriate		
	АА	5,522,215	6/4/1996	Matsunaga et al.					
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	AD								
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		OTHER RE	FERENCES (incl	luding Author, Title, I	Date, Pertinent P	ages, Etc.)		
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EXAMINER				DATE CONSIDERED					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									

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